SPWLA NewsLetter

SPWLA Japan Chapter

Vol. 5 No.3 May 1999

Invitation to 28th Chapter Meeting

We would like to announce that the forthcoming Chapter Meeting will be held as follows.

Venue

: Meeting Room (2F) of New Building

System Science and Mechanical Engineering

Graduate School of Engineering, Tohoku University, Sendai

Date

: Wednesday, 19th May, 1999

Program

:14:00

"Single-well sonic imaging for high-resolution reservoir descriptions

around the borehole"

by Shinichi Watanabe (Schlumberger K.K.)

"Development of subsurface micro sensors in Tohoku University"

by H. Niitsuma, M. Nishizawa and K. Hirata (Tohoku Univ.)

(See details below)

16:00 Facility Tour of Venture Business Laboratory and Niitshuma Laboratory

(See details in attached pages)

17:00 Snacks Buffet (Beer Party at Top of New Building)

Note: Those who will attend the meeting may contact Tezuka, JAPEX

tel: 043-275-9311/ tezuka@rc.japex.co.jp

About the Topics:

Single-well sonic imaging for high-resolution reservoir descriptions around the borehole Speaker: Shinichi Watanabe (Schlumberger K.K.)

In the acoustic measurement domain, single-well sonic imaging bridges the gap between Seismic/VSP and conventional sonic logging by utilizing and analyzing full-waveform data. The goal of single-well sonic imaging is to delineate reservoir structure in the vicinity of the borehole with higher resolution than Seismic/VSP imaging. Seismic processing methods are adopted to analyze reflected and scattered signals from structure around the borehole.

BARS (Borehole Acoustic Reflection Survey) was proposed as an application of sonic imaging with the aim of imaging reflectors and fractures using a tool with a longer T-R spacing than conventional sonic tools. We will present BARS methodology including pre-job modeling, data acquisition, data processing, and interpretation.

Development of subsurface micro sensors in Tohoku University Speaker: H. Niitsuma, M. Nishizawa and K. Hirata (Tohoku University)

In this talk, the potential of subsurface micro sensing in various areas and current status of development of subsurface sensors, especially for micro seismic sensors in Tohoku University will be presented. Following to an overall introduction by Prof. Niitsuma, Mr Nishizawa and Mr. Hirata will present the details of two types of micro sensors. The prototypes of these sensors can be seen through the facility tour of Niitsuma Laboratory.

I will introduce and demonstrate the system.

['94-'95 Annual schedule of Chapter Meetings]

May 23, 1994 Japan National Oil Corporation July 25, 1994 Japan Petroleum Exploration Co.,Ltd

September 27, 1994 Japan Oil Engineering Co.,Ltd

November 29, 1994 Technical Research Center, Teikoku Oil Co., Ltd

January 23, 1995 Indonesia Petroleum, Inc.

March 13, 1995 Waseda University

May 29, 1995 Japan Oil Development Co.,Ltd

September 21-22, 1995 Technology Research Center, Japan National Oil Corporation

['95-'96 Annual schedule of chapter meeting]

November 27, 1995 Idemitsu Oil Development Co.,Ltd January 29, 1996 Geothermal Energy R& D Co.,Ltd

March 26, 1996 Arabian Oil Co.,Ltd

May 27, 1996 Japan Petroleum Exploration Co.,Ltd

September 26-27, 1996 Technology Research Center, Japan National Oil Corporation

['96-'97 Annual schedule of Chapter meetings]

November 25, 1996 Technical Research Center, Teikoku Oil Co.,Ltd

January 27, 1997 Indonesia Petroleum, Inc.

March 26, 1997 Waseda University

May 26, 1997 Japan Oil Development Co., Ltd.

September 24-25, 1997 Technology Research Center, Japan National Oil Corporation

['97-'98 Annual schedule of Chapter meetings]

November 25, 1997 Idemitsu Oil Development Co.,Ltd January 26, 1998 Geothermal Energy R& D Co.,Ltd

March 30, 1998 Schlumberger K.K.

May 25, 1998 Japan Petroleum Exploration Co.,Ltd

September 24-25, 1998 Technology Research Center, Japan National Oil Corporation

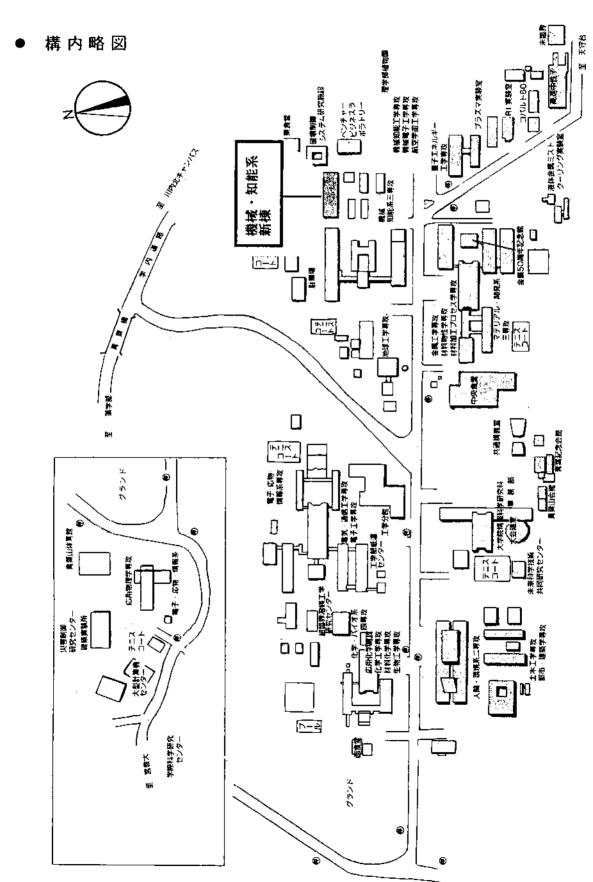
['98-'99 Annual schedule of Chapter meetings]

November 27, 1998 Technical Research Center, Teikoku Oil Co., Ltd

January 27, 1999 Indonesia Petroleum, Inc.

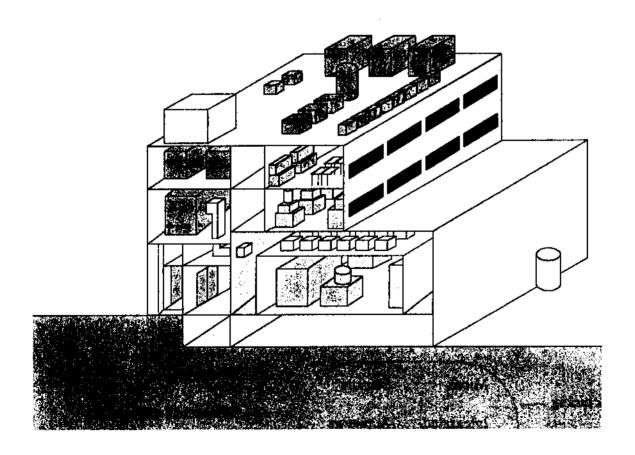
March 31, 1999 Waseda University
May 19, 1999 Tohoku University

September 29-30, 1999 Technology Research Center, Japan National Oil Corporation



Venture Business Laboratory (VBL) Tohoku University

Development of Sensors and Micromachines (Micro Nano-Machining)



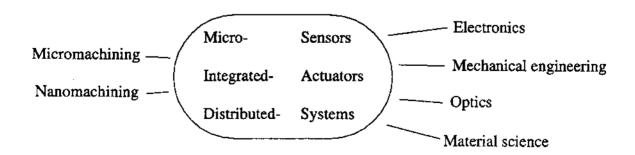
Objectives of VBL in Tohoku University

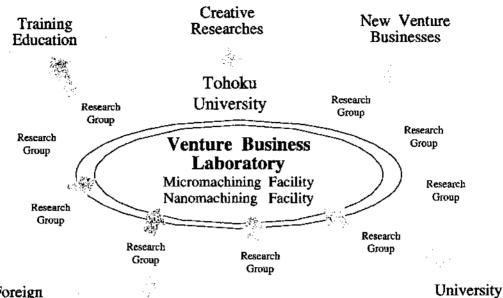
VBL in Tohoku University was established by the fund for creative research projects in the 1995 fiscal year supplementary budget of Japanese Government. The responsibilities for research and development in VBL are shared amongst all the faculties of Tohoku University. The faculty of Engineering maintains the prime responsibility for the VBL. VBL's primary mission is educational and to provide the facilities and working environment that makes possible graduate education through research in the area of "Sensor and Micromachine technologies" (Micro- and Nano-Machining) and "Integrated Microsystem technologies". The objectives of the VBL are epitomized in the three major roles of the laboratory as stated below.

- 1) Promoting creative research and practical development that generate new business.
- 2) Bringing up of creative person who has advanced professional ability and venture spirit.
- Providing graduate school with facilities for education and research including large-sized special equipment.

For the above purposes, a new building for "sensor and micromachine" and "integrated microsystems" has been constructed in Aoba-yama campus in addition to improving and rearranging the existing micromachining facilities. The building includes LSI fabrication facilities. We push forward with new idea from young researchers, especially graduate school students, and train the student until he has a wide variety of professional ability through interdisciplinary cooperation of the individual departments and graduate schools. The cooperative research projects accepting researchers from industries, universities and governments are promoted actively. International exchange through the fellowships for foreign scientists and dispatch of young scientists for research abroad are performed actively. The scientific and technological results obtained from the VBL will be distributed worldwide.

Major research fields in VBL

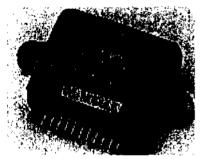




Foreign Country

Government Laboratory

Private Corporation



Integrated capacitive pressure sensor (Toyoda Machine Works LTD)



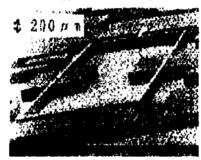
pH, CO2 monitor catheter (Nippon Kohden Corp.)



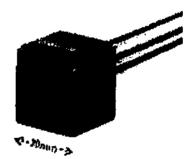
Multi-link active catheter



Integrated electrostatic servo accelerometer



Silicon tuning fork fabricated using RIE



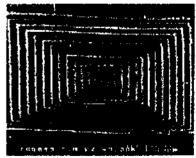
Bakable microvalve



1 µm thick silicon cantilever parallel to a glass for capacitive AFM probe



Silicon nano-wire grown by field evaporation in UHV-STM



Silicon self-supported nano-structure fabricated by STM drawing